

Notice of References CitedApplication/Control No.
09/595,583Applicant(s)/Patent Under
Reexamination
MIZE ET AL.Examiner
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,674,926	07-1972	Dewey et al.	348/138
	B	US-5,502,306	03-1996	Meisburger et al.	250/310
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Udler et al. "Tungsten-Titanium Sputtering Target Technology", Advanced Materials Division, Technial Note 203, 1994
	V	http://www.iamaterials.com/sputter/targets.htm , International Advanced Materials, 1999
	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.